



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
www.uspto.gov



CONFIRMATION NO. 4607

Bib Data Sheet

SERIAL NUMBER 10/512,405	FILING OR 371(c) DATE 06/15/2005 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. 474082002800
-----------------------------	--	--------------	------------------------	--

APPLICANTS

Nobumitsu Takase, Tokyo, JAPAN;
 Hideshi Nishikawa, Tokyo, JAPAN;
 Makoto Ito, Tokyo, JAPAN;
 Koji Sueoka, Tokyo, JAPAN;
 Shinsuke Sadamitsu, Tokyo, JAPAN;

**** CONTINUING DATA *******

This application is a 371 of PCT/JP03/04866 04/16/2003

**** FOREIGN APPLICATIONS *******

JAPAN 2002-127509 04/26/2002

JAPAN 2002-360731 12/12/2002

Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 6	TOTAL CLAIMS 17	INDEPENDENT CLAIMS 4
35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance				
Verified and Acknowledged Examiner's Signature _____ Initials _____				

ADDRESS

25227

TITLE

High resistance silicon wafer and method for production thereof

FILING FEE RECEIVED 1594	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
-----------------------------	---	---